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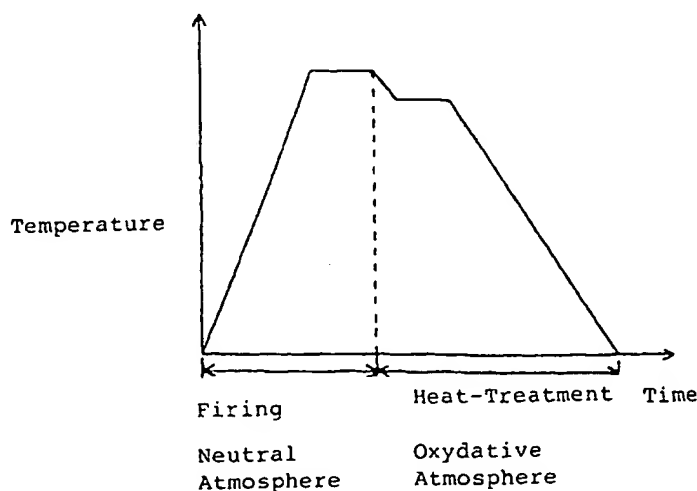
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(54) **Composite material for positive temperature coefficient thermistor and method of manufacturing**

(57) The object of the present invention is to provide a ceramic for the PTC thermistor having a resistivity at room temperature of $5 \Omega \cdot \text{cm}$ or less, static withstanding voltage of 60 V/mm or more and temperature resistance coefficient of $9.0 \text{ }^\circ\text{C}^{-1}$ along with having small dispersion of the resistance, wherein the ceramic for the PTC thermistor is composed of principal components of 30 to 97 molar percentage (mol%) of BaTiO_3 , 1 to 50 mol% of PbTiO_3 , 1 to 30 mol% of SrTiO_3 and 1 to 25 mol% of

CaTiO_3 (the total content of them accounts for 100 mol%), as well as 0.1 to 0.3 mole of samarium oxide in terms of Sm element, 0.01 to 0.03 mole of manganese oxide in terms of Mn element and 0 to 2.0 mole of silicon oxide in terms of Si element relative to 100 moles of the principal components, the composite material being preferably heat-treated in an oxidative atmosphere after being fired in a reducing atmosphere for obtaining the ceramic.

FIG. 1



material for the PTC thermistor according to the first aspect in a neutral atmosphere followed by heat-treatment in an oxidative atmosphere.

[0014] The present invention also provides a ceramic for use in the PTC thermistor obtained by firing the composite material for the PTC thermistor according to the first aspect in a reducing atmosphere followed by heat-treatment in an oxidative atmosphere.

[0015] The present invention also provides a method for manufacturing a ceramic for use in the PTC thermistor.

[0016] In one aspect, the present invention provides a method for manufacturing the ceramic for use in the PTC thermistor provided with the step of firing the composite material for the PTC thermistor in a neutral atmosphere followed by heat-treating in an oxidative atmosphere.

[0017] In another aspect, the present invention provides a method for manufacturing the ceramic for use in the PTC thermistor provided with the step of firing the composite material for the PTC thermistor in a reducing atmosphere followed by heat-treatment in an oxidative atmosphere.

[0018] A nitrogen atmosphere may be used for the neutral atmosphere. While air containing about 20% of oxygen or a high oxygen containing atmosphere containing about 100% of oxygen may be used for the oxidative atmosphere. An atmosphere containing 1% of hydrogen and 99% of nitrogen may be used for the reducing atmosphere.

BRIEF DESCRIPTION OF THE DRAWINGS

[0019] Fig. 1 shows a firing profile used for executing Example 2 or 5 according to the present invention.

[0020] Fig. 2 is a firing profile used for executing Example 3 or 6 according to the present invention.

DESCRIPTION OF THE PREFERRED EMBODIMENT

(Example 1)

[0021] BaCO_3 , TiO_2 , PbO , SrCO_3 , CaCO_3 , Sm_2O_3 , MnCO_3 and SiO_2 were used as starting materials and they were mixed in the proportions shown in TABLE 1 with wet mixing. The term "Ba", "Pb", "Sr" and "Ca" in TABLE 1 denote the composition ratios of " BaTiO_3 ", " PbTiO_3 ", " SrTiO_3 " and " CaTiO_3 ", respectively. The composition ratios of " BaTiO_3 ", " PbTiO_3 ", " SrTiO_3 " and " CaTiO_3 " to serve as principal components are expressed by mol% units (the combined amount of them accounts for 100%) while "Sm", "Mn" and " SiO_2 " to serve as additives are expressed in mol% relative to 100 moles of the principal components.

TABLE 1

No.	Ba	Pb	Sr	Ca	Sm	Mn	SiO_2	
1-1	97.0	1	1	1	0.2	0.02	1	
1-2	60.0	10	15	15	0.2	0.02	1	
1-3	40.0	30	15	15	0.2	0.02	1	
1-4	20.0	50	15	15	0.2	0.02	1	*
1-5	30.0	50	10	10	0.2	0.02	1	
1-6	30.0	60	5	5	0.2	0.02	1	*
1-7	74.0	10	1	15	0.2	0.02	1	
1-8	45.0	10	30	15	0.2	0.02	1	
1-9	35.0	10	40	15	0.2	0.02	1	*
1-10	74.0	10	15	1	0.2	0.02	1	
1-11	50.0	10	15	25	0.2	0.02	1	
1-12	45.0	10	15	30	0.2	0.02	1	*
1-13	60.0	10	15	15	0.05	0.02	1	*
1-14	60.0	10	15	15	0.1	0.02	1	
1-15	66.0	10	15	15	0.3	0.02	1	

(The mark "*" denotes that the composition is out of the range of the present invention)

TABLE 2 (continued)

No.	$\rho_{25}(\Omega \cdot \text{cm})$	STATIC WITHSTANDING VOLTAGE (V/mm)	$\alpha(\%/^{\circ}\text{C})$	SCATTERING OF RESISTANCE (CV %)	
1-9	6.6	105	13.2	5.5	*
1-10	2.8	70	10.4	3.4	
1-11	4.1	100	12.2	3.7	
1-12	5.2	105	12.5	3.9	*
1-13	5.6	115	13.6	4.3	*
1-14	4.5	105	12.9	3.6	
1-15	3.2	75	10.1	3.5	
1-16	4.1	60	8.7	3.6	*
1-17	2.0	55	9.4	3.1	*
1-18	2.3	70	10.0	3.4	
1-19	4.8	110	13.0	3.8	
1-20	7.3	130	14.4	5.2	*
1-21	4.2	100	12.3	3.7	
1-22	5.5	110	12.7	4.3	*

(The mark "*" denotes that the composition is out of the range of the present invention)

[0028] Alternately, the PTC thermistors were manufactured as comparative examples using respective compositions in TABLE 3 by the same method as used in Examples. While Sm_2O_3 was used as a starting material for the semiconductor forming agent in the foregoing examples, any one of La_2O_3 , Y_2O_3 , Sb_2O_3 and Nb_2O_3 was used as a starting material for each semiconductor forming agent in the comparative examples instead of Sm_2O_3 in the example.

TABLE 3

No.	Ba	Pb	Sr	Ca	SEMICONDUCTOR FORMING AGENT		Mn	SiO_2
1-23	60.0	10	15	15	La	0.2	0.02	1
1-24	60.0	10	15	15	Y	0.25	0.02	1
1-25	60.0	10	15	15	Sb	0.2	0.02	1
1-26	60.0	10	15	15	Nb	0.2	0.02	1

[0029] The term "Ba", "Pb", "Sr" and "Ca" in TABLE 3 denote, as in TABLE 1, the composition ratios of " BaTiO_3 ", " PbTiO_3 ", " SrTiO_3 " and " CaTiO_3 ", respectively. The composition ratios of " BaTiO_3 ", " PbTiO_3 ", " SrTiO_3 " and " CaTiO_3 " to serve as principal components are expressed by mol% (the combined amount of them accounts for 100%) while "the semiconductor forming agents (La, Y, Sb and Nb)", "Mn" and "S" to serve as additives are expressed in mol% relative to 100 moles of the principal components.

[0030] Respective characteristics of the samples in the comparative examples were evaluated by the same method as used in the examples described above. The results are listed in TABLE 4

TABLE 4

No.	$\rho_{25}(\Omega \cdot \text{cm})$	STATIC WITHSTANDING VOLTAGE (V/mm)	$\alpha(\%/^{\circ}\text{C})$	SCATTERING OF RESISTANCE (CV %)
1-23	2.9	85	10.0	7.0
1-24	6.0	120	12.5	3.4
1-25	2.8	75	9.5	7.0
1-26	3.1	80	9.5	6.5

TABLE 8 and TABLE 9 below. TABLE 8 shows the neutral atmospheres for firing and oxidative atmosphere for the heat-treatment to be applied to each sample as in TABLE 6, while TABLE 9 shows the results of evaluations as shown in TABLE 7.

TABLE 8

No.	FIRING ATMOSPHERE	HEAT-TREATMENT ATMOSPHERE
2-23	N ₂ 100%	O ₂ 100%
2-24	N ₂ 100%	O ₂ 100%
2-25	N ₂ 100%	O ₂ 100%
2-26	N ₂ 100%	O ₂ 100%

TABLE 9

No.	$\rho_{25}(\Omega \cdot \text{cm})$	STATIC WITHSTANDING VOLTAGE (V/mm)	α (%/ °C)	SCATTERING OF RESISTANCE (CV %)
2-23	2.1	65	10.0	6.3
2-24	4.0	80	12.0	3.1
2-25	2.0	60	9.5	6.5
2-26	2.2	60	9.5	6.2

[0053] The sample numbers 2-23 to 2-26 in TABLE 8 and 9 correspond to the sample numbers 1-23 to 1-26 in TABLE 3 and TABLE 4, respectively, in which the same compositions are used in the samples with the same sample numbers with each other.

[0054] In comparing the samples in the comparative examples shown in TABLE 9 with the samples with the compositions within the range of the present invention shown in TABLE 7, or comparing the samples in the comparative examples shown in TABLE 4 with the samples with the compositions within the range of the present invention shown in TABLE 2, the same tendencies in the former comparison are also seen in the latter comparison. However, it can be understood that the effect for decreasing the resistivity at room temperature (ρ_{25}) by firing in a neutral atmosphere and heat-treatment in an oxidative atmosphere is recognizable in the comparative examples when the comparative examples shown in TABLE 9 are compared with the comparative examples shown in TABLE 4.

(Example 3)

[0055] The firing profile as shown in FIG. 2 is used in Example 3 for firing the molded bodies comprising the composite materials for the PTC thermistors. In short, after firing the molded bodies in a reducing atmosphere such as the H₂/N₂ atmosphere, the molded bodies were heat-treated in an oxidative atmosphere such as in a high oxygen concentration atmosphere or in the air.

[0056] Except for the firing profile as described above, the molded bodies of the examples and comparative examples in Example 3 were obtained by the same treatment as described in the examples and comparative examples in Example 1 using the same compositions listed in TABLE 1 and TABLE 3. Electrodes were formed on the sintered bodies after firing by the same method as in Example 1 to manufacture the PTC thermistors to evaluate their characteristics.

[0057] Neutral atmospheres for firing under the firing profile and oxidative atmospheres for the heat-treatment shown in FIG. 2 are applied for respective samples shown in TABLE 10 below.

TABLE 10

No.	FIRING ATMOSPHERE	HEAT-TREATMENT ATMOSPHERE	
3-1	H ₂ 1%/N ₂ 99%	O ₂ 100%	
3-2-1	H ₂ 1%/N ₂ 99%	O ₂ 100%	
3-2-2	H ₂ 1%/N ₂ 99%	O ₂ 20%	
3-3	H ₂ 1%/N ₂ 99%	O ₂ 100%	

TABLE 11 (continued)

No.	$\rho_{25}(\Omega\cdot\text{cm})$	STATIC WITHSTANDING VOLTAGE (V/mm)	$\alpha(\%/^{\circ}\text{C})$	SCATTERING OF RESISTIVITY (CV %)	
3-12	3.6	80	13.5	3.7	*
3-13	3.8	90	14.3	3.9	*
3-14	3.1	85	13.9	3.3	
3-15	2.3	65	10.9	3.1	
3-16	2.8	45	9.5	3.5	*
3-17	1.6	45	10.1	3.2	*
3-18	1.8	60	10.8	3.4	
3-19	3.1	85	13.9	3.6	
3-20	4.8	90	15.6	3.8	*
3-21	2.9	85	13.0	3.3	
3-22	3.7	80	13.8	3.4	*

(The mark (*) denotes that the composition is out of the range of the present invention)

[0059] The sample numbers 3-1 to 3-22 in TABLE 10 and 11 correspond to the sample numbers 1-1 to 1-22 in TABLE 1 and TABLE 2, respectively, in which the samples with the same sample numbers with each other have the same compositions.

[0060] The samples with the sample number 3-2 in TABLE 10 and TABLE 11 were heat-treated under different two kinds of oxidative atmospheres in the firing profile shown in FIG. 2. Accordingly, the samples were distinguished with each other by attaching sub-numbers as 3-2-1 and 3-2-2.

[0061] TABLE 11 shows that the samples with the compositions within the range of the present invention have the resistivities at room temperature (ρ_{25}) of 3.5 $\Omega\cdot\text{cm}$ or less, static withstanding voltages of 50 V/mm or more and temperature resistance coefficients (α) of 10.8 $\%/^{\circ}\text{C}$, enabling to obtain the PTC thermistors with small scattering of resistance (CV %).

[0062] When the resistivities at room temperature (ρ_{25}) is especially noticed, more lower values could be obtained as compared with the samples in TABLE 2 or TABLE 7 whose compositions are within the range of the present invention because the effect of firing in a reducing atmosphere and heat-treatment in an oxidative atmosphere had been expressed to increase the concentration of conductive electrons in the grains due to such firing and heat-treatment.

[0063] It is also evident from the comparison between the samples 3-2-1 and 3-2-2 in TABLE 10 and TABLE 11 that the oxygen concentration during the heat-treatment steps in the firing profile shown in FIG. 2 has substantially no effects on the characteristics of the PTC thermistors in the oxygen concentration range from 20 to 100%.

[0064] The same tendencies as the comparison of these samples in TABLE 2 are recognizable when the samples with the concentrations within the range of the present invention are compared with the samples with the concentrations out of the range of the present invention in TABLE 11.

[0065] The comparative examples in which semiconductor forming agents other than Sm were used are listed in TABLE 12 and TABLE 13 below. TABLE 12 shows the neutral atmospheres for the sintering step and oxidative atmosphere for the heat-treatment to be applied to each sample as in TABLE 10, while TABLE 13 shows the results of evaluations as shown in TABLE 11.

TABLE 12

No.	SINTERING ATMOSPHERE	HEAT-TREATMENT ATMOSPHERE
2-23	H ₂ 1%/N ₂ 99%	O ₂ 100%
2-24	H ₂ 1%/N ₂ 99%	O ₂ 100%
2-25	H ₂ 1%/N ₂ 99%	O ₂ 100%
2-26	H ₂ 1%/N ₂ 99%	O ₂ 100%

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TABLE 14 (continued)

No.	Ba	Pb	Sr	Ca	Sm	Mn	SiO ₂	
4-13	60.0	10	15	15	0.05	0.02	0	*
4-14	60.0	10	15	15	0.1	0.02	0	
4-15	60.0	10	15	15	0.3	0.02	0	
4-16	60.0	10	15	15	0.4	0.02	0	*
4-17	60.0	10	15	15	0.2	0.005	0	*
4-18	60.0	10	15	15	0.2	0.01	0	
4-19	60.0	10	15	15	0.2	0.03	0	
4-20	60.0	10	15	15	0.2	0.04	0	*

(The mark (*) denotes that the composition is out of the range of the present invention)

[0070] The compositions shown in TABLE 14 were subsequently subjected to dehydration, drying, calcination, molding and sintering steps followed by forming external electrodes under the substantially same conditions as used in Example 1 to obtain PTC thermistors as samples. Then, the resistivities at room temperature (ρ_{25}), static withstanding voltages, temperature resistance coefficients (α) and dispersions of the resistance (CV %) were determined with respect to the PTC thermistors.

[0071] TABLE 15 shows the resistivities at room temperature (ρ_{25}), static withstanding voltages, temperature resistance coefficients (α) and dispersions of the resistance (CV %) of the samples listed in TABLE 14.

TABLE 15

No.	$\rho_{25}(\Omega \cdot \text{cm})$	Static withstanding voltage (V/mm)	$\alpha(\%/^\circ\text{C})$	DISPERSION OF RESISTIVITY (CV %)	
4-1	2.0	60	9.0	2.9	
4-2	2.7	75	10.5	3.3	
4-3	3.4	95	12.0	3.6	
4-4	5.1	105	13.1	3.4	*
4-5	4.7	95	12.1	3.6	
4-6	5.3	90	11.7	3.6	*
4-7	2.4	60	9.3	3.0	
4-8	4.0	85	11.6	3.6	
4-9	6.1	90	12.2	5.2	*
4-10	2.5	60	9.4	3.0	
4-11	3.6	85	11.2	3.4	
4-12	5.1	90	11.5	3.5	*
4-13	5.1	100	12.6	4.0	*
4-14	4.0	90	11.9	3.3	
4-15	2.9	60	9.1	3.1	
4-16	3.6	50	7.7	3.4	*
4-17	1.5	50	8.4	2.8	*
4-18	2.0	60	9.0	3.2	
4-19	4.3	100	12.0	3.5	

(The mark (*) denotes that the composition is out of the range of the present invention)

TABLE 16 (continued)

No.	FIRING ATMOSPHERE	HEAT-TREATMENT ATMOSPHERE	
5-17	N ₂ 100%	O ₂ 100%	*
5-18	N ₂ 100%	O ₂ 100%	
5-19	N ₂ 100%	O ₂ 100%	
5-20	N ₂ 100%	O ₂ 100%	*

(The mark (*) denotes that the composition is out of the range of the present invention)

[0078] The resistivities at room temperature (ρ_{25}), static withstanding voltages, temperature resistance coefficients (α) and dispersions of the resistances (CV %) of the samples listed in TABLE 16 are shown in TABLE 17 below.

TABLE 17

No.	$\rho_{25}(\Omega\cdot\text{cm})$	STATIC WITHSTANDING VOLTAGE (V/mm)	$\alpha(\%/^{\circ}\text{C})$	DISPERSION OF RESISTIVITY (CV %)	
5-1	1.5	50	10.0	3.0	
5-2-1	2.0	60	11.5	3.0	
5-2-2	1.9	60	11.0	3.1	
5-3	2.4	75	13.0	3.0	
5-4	3.6	85	14.3	3.9	*
5-5	3.2	80	13.1	2.9	
5-6	3.6	70	13.2	3.9	*
5-7	1.8	50	10.3	3.0	
5-8	2.9	65	12.6	3.3	
5-9	4.1	60	13.2	3.8	*
5-10	1.8	55	10.4	3.1	
5-11	2.5	65	12.2	3.3	
5-12	3.6	75	13.0	3.8	*
5-13	3.6	80	13.6	3.7	*
5-14	2.8	75	12.9	3.2	
5-15	2.1	50	10.1	3.0	
5-16	2.5	35	8.7	3.3	*
5-17	1.4	40	9.4	3.0	*
5-18	1.5	50	10.0	3.2	
5-19	2.9	75	13.0	3.5	
5-20	4.5	80	14.4	3.9	*

(The mark (*) denotes that the composition is out of the range of the present invention)

[0079] The samples 5-1 to 5-20 in TABLE 16 and TABLE 17 correspond to the samples 4-1 to 4-20 in TABLE 14 and TABLE 15, respectively, in which the same composite materials are used for each sample having the same sample numbers.

[0080] The samples with the sample number 5-2 in TABLE 16 and TABLE 17 were heat-treated under different two kinds of oxidative atmospheres in the firing profile shown in FIG. 1. Accordingly, the samples were distinguished with each other by attaching sub-numbers as 5-2-1 and 5-2-2.

[0081] TABLE 17 shows that the samples having the compositions within the range of the present invention have the resistivities at room temperature (ρ_{25}) of 3.5 $\Omega\cdot\text{cm}$ or less, static withstanding voltage of 50 V/mm or more and

TABLE 18 (continued)

No.	FIRING ATMOSPHERE	HEAT-TREATMENT ATMOSPHERE	
6-20	H ₂ 1%/N ₂ 99%	O ₂ 100%	*

(The mark (*) denotes that the composition is out of the range of the present invention)

[0088] The resistivities at room temperature (ρ_{25}), static withstanding voltages, temperature resistance coefficients (α) and dispersions of the resistances (CV %) of the samples listed in TABLE 18 are shown in TABLE 19 below.

TABLE 19

No.	$\rho_{25}(\Omega \cdot \text{cm})$	STATIC WITHSTANDING VOLTAGE (V/mm)	$\alpha(\%/^{\circ}\text{C})$	DISPERSION OF RESISTIVITY (CV %)	
6-1	1.4	50	10.1	3.0	
6-2-1	2.0	60	11.4	2.9	
6-2-2	1.7	60	11.2	3.2	
6-3	2.3	75	13.1	3.0	
6-4	3.6	80	14.4	3.9	*
6-5	3.1	80	14.2	2.6	
6-6	3.6	70	13.1	3.9	*
6-7	1.7	50	10.1	3.1	
6-8	2.7	65	12.5	3.4	
6-9	4.1	60	13.3	3.8	*
6-10	1.6	55	10.5	3.3	
6-11	2.5	65	12.2	3.5	
6-12	3.4	75	12.9	3.8	*
6-13	3.6	80	13.5	3.7	*
6-14	2.8	75	13.0	3.0	
6-15	1.9	50	10.1	3.0	
6-16	2.4	40	8.6	3.5	*
6-17	1.3	40	9.4	3.1	*
6-18	1.5	50	9.7	3.3	
6-19	2.7	75	13.0	3.7	
6-20	4.5	80	14.6	3.9	*

(The mark (*) denotes that the composition is out of the range of the present invention)

[0089] The samples 6-1 to 6-20 in TABLE 18 and TABLE 19 correspond to the samples 4-1 to 4-20 in TABLE 14 and TABLE 15, respectively, in which the same composite materials are used for each sample having the same sample numbers.

[0090] The samples with the sample number 6-2 in TABLE 18 and TABLE 19 were heat-treated under different two kinds of oxidative atmospheres in the firing profile shown in FIG. 2. Accordingly, the samples were distinguished with each other by attaching sub-numbers as 6-2-1 and 6-2-2.

[0091] TABLE 19 shows that the samples having the compositions within the range of the present invention have the resistivities at room temperature (ρ_{25}) of 3.5 $\Omega \cdot \text{cm}$ or less, static withstanding voltage of 50 V/mm or more and temperature resistance coefficients (α) of 9.7 %/ $^{\circ}\text{C}$ or less, enabling to obtain the PTC resistors having small dispersion of resistivities (CV %).

[0092] Notice the resistivities at room temperature (ρ_{25}), then it is clear that the samples having the compositions within the range of the present invention in TABLE 19 have smaller values as compared with the samples having the

6. A method for manufacturing the ceramic for use in the PTC thermistor provided with the step of firing the composite material for the PTC thermistor in a reducing atmosphere followed by heat-treating in an oxidative atmosphere.

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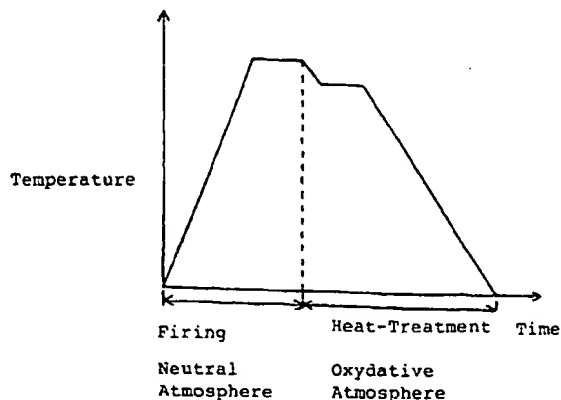
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(54) **Composite material for positive temperature coefficient thermistor and method of manufacturing**

(57) The object of the present invention is to provide a ceramic for the PTC thermistor having a resistivity at room temperature of $5 \Omega \cdot \text{cm}$ or less, static withstanding voltage of 60 V/mm or more and temperature resistance coefficient of 9.0 $\% / ^\circ \text{C}$ along with having small dispersion of the resistance, wherein the ceramic for the PTC thermistor is composed of principal components of 30 to 97 molar percentage (mol%) of BaTiO_3 , 1 to 50 mol% of PbTiO_3 , 1 to 30 mol% of SrTiO_3 and 1 to 25 mol% of

CaTiO_3 (the total content of them accounts for 100 mol%), as well as 0.1 to 0.3 mole of samarium oxide in terms of Sm element, 0.01 to 0.03 mole of manganese oxide in terms of Mn element and 0 to 2.0 mole of silicon oxide in terms of Si element relative to 100 moles of the principal components, the composite material being preferably heat-treated in an oxidative atmosphere after being fired in a reducing atmosphere for obtaining the ceramic.

FIG. 1



EP 0 974 982 A3

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Application Number
EP 99 11 4629

DOCUMENTS CONSIDERED TO BE RELEVANT			
Category	Citation of document with indication, where appropriate, of relevant passages	Relevant to claim	CLASSIFICATION OF THE APPLICATION (Int.Cl.7)
X	EP 0 642 140 A (MATSUSHITA ELECTRIC IND CO LTD) 8 March 1995 (1995-03-08) * page 3 - page 4 *	1,2	H01C7/02
A	---	3-6	
A	US 4 126 583 A (WALTER ULRICH) 21 November 1978 (1978-11-21) * example 3 *	1-6	
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A	EP 0 280 819 A (TAIYO YUDEN KK) 7 September 1988 (1988-09-07) * page 1, line 5-44 * * page 11, line 15-18 *	1-6	
A	---		
A	PATENT ABSTRACTS OF JAPAN vol. 015, no. 263 (C-0847), 4 July 1991 (1991-07-04) & JP 03 088770 A (CENTRAL GLASS CO LTD), 15 April 1991 (1991-04-15) * abstract *	1,2	

			TECHNICAL FIELDS SEARCHED (Int.Cl.7)
			H01C
The present search report has been drawn up for all claims			
Place of search THE HAGUE		Date of completion of the search 24 October 2000	Examiner Odgers, M
CATEGORY OF CITED DOCUMENTS X : particularly relevant if taken alone Y : particularly relevant if combined with another document of the same category A : technological background O : non-written disclosure P : intermediate document T : theory or principle underlying the invention E : earlier patent document, but published on, or after the filing date D : document cited in the application L : document cited for other reasons & : member of the same patent family, corresponding document			

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FIG. 1

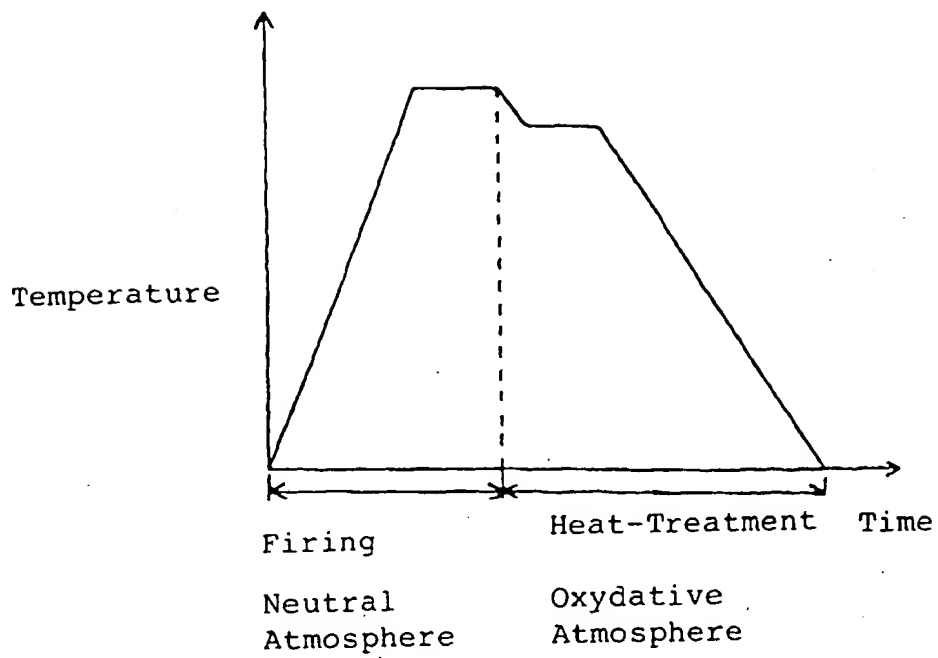
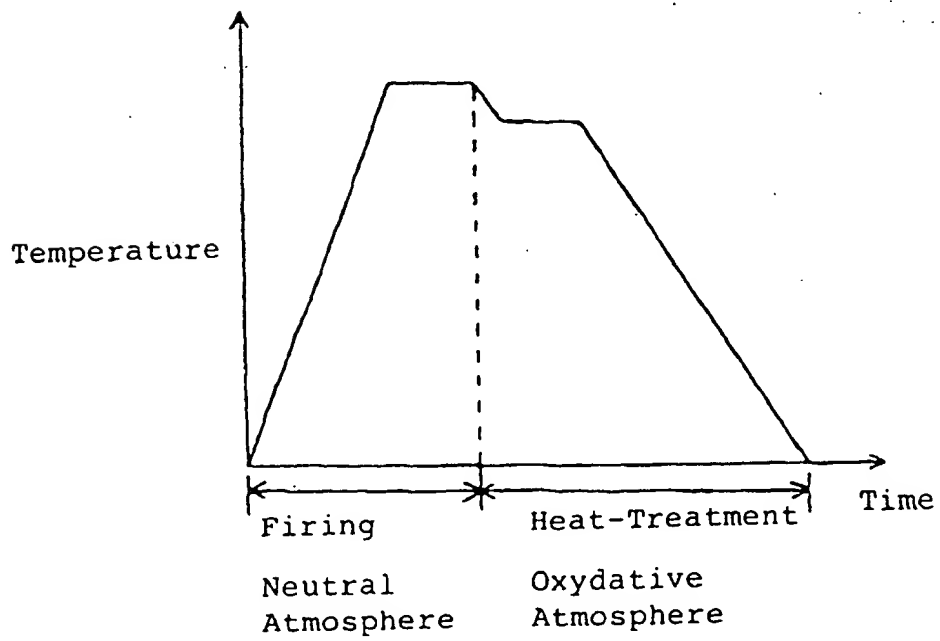


FIG. 2



compositions within the range of the present invention in TABLE 15, or as compared with the samples having the compositions within the range of the present invention in TABLE 17. This is because the effects of firing in the neutral atmosphere and heat-treatment in the oxidative atmosphere have been displayed to increase the concentration of conductive electrons in the grains due to such firing and heat-treatment steps.

[0093] As shown by the comparison of the sample 6-2-1 with the sample 6-2-2, the oxygen concentration within the range of 20 to 100% in the heat-treatment step in accordance with the firing profile shown in FIG. 2 has substantially no effect on the characteristics of the PTC thermistors.

[0094] Compare the samples having the compositions within the range of the present invention with the samples having the compositions out of the range of the present invention in TABLE 19, then it can be seen that the same tendency obtained by comparison among these two kinds of samples in TABLE 15 are also displayed in TABLE 19.

[0095] According to the present invention as hitherto described, Sm is used for the semiconductor forming agent to be contained in a prescribed quantity in the composite material for used in the barium titanate based PTC thermistors. Accordingly, the ceramic for the PTC thermistor obtained by firing the composite material described above has the resistivity at room temperature can be lowered, for example, to 5 Ω -cm or less, the static withstanding voltage can be increased, for example, to 50 to 60 V/mm or more and the temperature resistance coefficient can be increased, for example, to 9 %/°C, along with reducing dispersion of the resistance. Therefore, the PTC thermistor to be used for protecting electric circuits can be manufactured with excellent productivity.

[0096] Firing the composite material for the PTC thermistor according to the present invention in a neutral atmosphere followed by heat-treating in an oxidative atmosphere allows the ceramic for the PTC thermistor to have a lower resistivity at room temperature.

[0097] When a reducing atmosphere is used in the foregoing firing step instead of the neutral atmosphere, the resistivity at room temperature can be more reduced.

Claims

1. A composite material for a PTC thermistor containing as principal components:

30 to 97 molar percentages (mol%) of BaTiO_3 ;

1 to 50 mol% of PbTiO_3 ;

1 to 30 mol% of SrTiO_3 ; and

1 to 25 mol% of CaTiO_3 (wherein the total content of them accounts for 100 mol%), along with containing as additives:

0.1 to 0.3 moles of Sm in terms of Sm element in a compound containing Sm;

0.01 to 0.03 moles of Mn in terms of Mn element in a compound containing Mn; and

0 to 2.0 moles of Si in terms of Si element in a compound containing Si, relative to 100 moles of the principal components.

2. A ceramic for use in a PTC thermistor containing as principal components:

30 to 97 molar percentages (mol%) of BaTiO_3 ;

1 to 50 mol% of PbTiO_3 ;

1 to 30 mol% of SrTiO_3 ; and

1 to 25 mol% of CaTiO_3 (wherein the total content of them accounts for 100 mol%), along with containing as additives:

0.1 to 0.3 moles of Sm in terms of Sm element in samarium oxide;

0.01 to 0.03 moles of Mn in terms of Mn element in manganese oxide; and

0 to 2.0 moles of Si in terms of Si element in silicon oxide, relative to 100 mole of the principal components.

3. A ceramic for use in the PTC thermistor obtained by firing the composite material for the PTC thermistor according to Claim 1 in a neutral atmosphere followed by heat-treating in an oxidative atmosphere.

4. A ceramic for use in the PTC thermistor obtained by firing the composite material for the PTC thermistor according to Claim 1 in a reducing atmosphere followed by heat-treating in an oxidative atmosphere.

5. A method for manufacturing the ceramic for use in the PTC thermistor provided with the step of firing the composite material for the PTC thermistor in a neutral atmosphere followed by heat-treating in an oxidative atmosphere.

temperature resistance coefficients (α) of 10.0 %/°C or less, enabling to obtain the PTC resistors having small dispersion of resistivities (CV %).

[0082] Notice the resistivities at room temperature (ρ_{25}), then it is clear that the samples having the compositions within the range of the present invention in TABLE 17 have smaller values as compared with the samples having the compositions within the range of the present invention in TABLE 15. This is because the effects of firing in the neutral atmosphere and heat-treatment in the oxidative atmosphere have been displayed to increase the grain size in the ceramics due to such firing and heat-treatment steps.

[0083] As shown by the comparison of the sample 5-2-1 with the sample 5-2-2, the oxygen concentration within the range of 20 to 100% in the heat-treatment step in accordance with the firing profile shown in FIG. 1 has substantially no effect on the characteristics of the PTC thermistors.

[0084] Compare the samples having the compositions within the range of the present invention with the samples having the compositions out of the range of the present invention in TABLE 17, then it can be seen that the same tendency obtained by comparison among these two kinds of samples in TABLE 15 are also displayed in TABLE 17.

(Example 6)

[0085] The firing profile in which the molded bodies were heat-treated in an oxidative atmosphere after firing in a reducing atmosphere as shown in FIG. 2 was used in Example 6 for firing the molded bodies comprising the composite materials for the PTC thermistors.

[0086] The same composite materials and treatment conditions as used in the examples and comparative examples in Example 4 were also used in the examples and comparative examples in Example 6 to obtain the molded bodies, except that the firing profile as described above was used. Electrodes were formed on the sintered bodies after firing by the same method as used in Example 4 to manufacture the PTC thermistors as samples for the same evaluation.

[0087] The reducing atmosphere for firing and oxidative atmosphere for the heat-treatment for the firing profile shown in FIG. 2 applied to each sample are shown in TABLE 18.

TABLE 18

No.	FIRING ATMOSPHERE	HEAT-TREATMENT ATMOSPHERE	
6-1	H ₂ 1%/N ₂ 99%	O ₂ 100%	
6-2-1	H ₂ 1%/N ₂ 99%	O ₂ 100%	
6-2-2	H ₂ 1%/N ₂ 99%	O ₂ 20%	
6-3	H ₂ 1%/N ₂ 99%	O ₂ 100%	
6-4	H ₂ 1%/N ₂ 99%	O ₂ 100%	*
6-5	H ₂ 1%/N ₂ 99%	O ₂ 100%	
6-6	H ₂ 1%/N ₂ 99%	O ₂ 100%	*
6-7	H ₂ 1%/N ₂ 99%	O ₂ 100%	
6-8	H ₂ 1%/N ₂ 99%	O ₂ 100%	
6-9	H ₂ 1%/N ₂ 99%	O ₂ 100%	*
6-10	H ₂ 1%/N ₂ 99%	O ₂ 100%	
6-11	H ₂ 1%/N ₂ 99%	O ₂ 100%	
6-12	H ₂ 1%/N ₂ 99%	O ₂ 100%	*
6-13	H ₂ 1%/N ₂ 99%	O ₂ 100%	*
6-14	H ₂ 1%/N ₂ 99%	O ₂ 100%	
6-15	H ₂ 1%/N ₂ 99%	O ₂ 100%	
6-16	H ₂ 1%/N ₂ 99%	O ₂ 100%	*
6-17	H ₂ 1%/N ₂ 99%	O ₂ 100%	*
6-18	H ₂ 1%/N ₂ 99%	O ₂ 100%	
6-19	H ₂ 1%/N ₂ 99%	O ₂ 100%	

(The mark (*) denotes that the composition is out of the range of the present invention)

TABLE 15 (continued)

No.	$\rho_{25}(\Omega\cdot\text{cm})$	Static withstanding voltage (V/mm)	$\alpha(\%/^{\circ}\text{C})$	DISPERSION OF RESISTIVITY (CV %)	
4-20	6.8	120	13.4	4.8	*

(The mark (*) denotes that the composition is out of the range of the present invention)

[0072] While Sm is used for the semiconductor forming material in the samples 4-1 to 4-20 in TABLE 14 and TABLE 15, the samples marked by "*" denotes those having the compositions out of the range of the present invention.

[0073] It is evident from TABLE 14 and TABLE 15 that the resistivities at room temperature (ρ_{25}) of $5\Omega\cdot\text{cm}$ or less, static withstanding voltages of 60 V/mm and temperature resistance coefficients (α) of $9\%/^{\circ}\text{C}$ can be obtained with respect to the PTC thermistors manufactured by using the composite materials for the PTC thermistors having the compositions within the range of the present invention with less dispersions of the resistance at room temperature.

[0074] On the contrary, the samples 4-4, 4-6, 4-9, 4-12, 4-13 and 4-20 having the compositions out of the range of the present invention have the resistivities at room temperature (ρ_{25}) of $5\Omega\cdot\text{cm}$ or more and the samples 4-1 and 4-17 have the temperature resistance coefficients (α) of less than $10\%/^{\circ}\text{C}$.

(Example 5)

[0075] The firing profile as shown in FIG. 1 in which molded bodies were heat-treated in an oxidative atmosphere after firing in a neutral atmosphere was used as in Example 2 in firing the molded bodies comprising the composite materials for the PTC thermistors.

[0076] The same composite materials as shown in TABLE 14 and the same methods as used in the examples and comparative examples in Example 4 were used in the examples and comparative examples shown in Example 5, except that the firing profile as described above was used. Electrodes were formed on the sintered body after firing by the same method as used in Example 4 to manufacture the PTC thermistors to be evaluated as described previously.

[0077] The neutral atmosphere for firing and oxidative atmosphere for the heat-treatment shown in FIG. 1 were applied to each sample and the conditions are listed in TABLE 16.

TABLE 16

No.	FIRING ATMOSPHERE	HEAT-TREATMENT ATMOSPHERE	
5-1	N ₂ 100%	O ₂ 100%	
5-2-1	N ₂ 100%	O ₂ 100%	
5-2-2	N ₂ 100%	O ₂ 20%	
5-3	N ₂ 100%	O ₂ 100%	
5-4	N ₂ 100%	O ₂ 100%	*
5-5	N ₂ 100%	O ₂ 100%	
5-6	N ₂ 100%	O ₂ 100%	*
5-7	N ₂ 100%	O ₂ 100%	
5-8	N ₂ 100%	O ₂ 100%	
5-9	N ₂ 100%	O ₂ 100%	*
5-10	N ₂ 100%	O ₂ 100%	
5-11	N ₂ 100%	O ₂ 100%	
5-12	N ₂ 100%	O ₂ 100%	*
5-13	N ₂ 100%	O ₂ 100%	*
5-14	N ₂ 100%	O ₂ 100%	
5-15	N ₂ 100%	O ₂ 100%	
5-16	N ₂ 100%	O ₂ 100%	*

(The mark (*) denotes that the composition is out of the range of the present invention)

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TABLE 13

No.	$\rho_{25}(\Omega\text{-cm})$	STATIC WITHSTANDING VOLTAGE (V/mm)	α (%/ $^{\circ}\text{C}$)	SCATTERING OF RESISTANCE (CV %)
2-23	1.9	65	10.1	6.8
2-24	3.9	80	12.2	3.5
2-25	2.0	60	9.5	7.0
2-26	2.1	60	9.4	6.8

[0066] The sample numbers 3-23 to 3-26 in TABLE 12 and 13 correspond to the sample numbers 1-23 to 1-26 in TABLE 3 and TABLE 4, respectively, in which the same compositions are used in the samples with the same sample numbers with each other.

[0067] Compare the samples in the comparative examples shown in TABLE 13 with the samples with the compositions within the range of the present invention shown in TABLE 11, or compare the samples in the comparative examples shown in TABLE 4 with the samples with the compositions within the range of the present invention shown in TABLE 2, then the same tendencies in the former case are also seen in the latter case. However, it can be understood that the effect for decreasing the resistivity at room temperature (ρ_{25}) by firing in a neutral atmosphere and heat-treatment in an oxidative atmosphere is recognizable in the comparative examples when the comparative examples shown in TABLE 13 are compared with the comparative examples shown in TABLE 4.

[0068] In contrast to Examples 1 to 3 as hitherto described, SiO_2 is not used in the starting materials in the samples in Example 4 and in Examples to be described hereinafter, or the ceramics obtained do not contain SiO_2 . The atmospheres to be used in the firing and sintering steps in Examples 4, 5 and 6 correspond to the atmospheres in Examples 1, 2 and 3, respectively, as hitherto described.

(Example 4)

[0069] BaCO_3 , TiO_2 , PbO , SrCO_3 , CaCO_3 , Sm_2O_3 and MnCO_3 were used as starting materials and they were blended with wet-mixing to be the compositions as shown in TABLE 14. The terms "Ba", "Pb", "Sr" and "Ca" in TABLE 14 denote the composition ratios of the principal components " BaTiO_3 ", " PbTiO_3 ", " SrTiO_3 " and " CaTiO_3 ", respectively, represented by mol% (the combined amount of them accounts for 100 mol%) while the additives "Sm" and "Mn" are represented by molar ratios relative to 100 moles of the principal components. It should be noted that the content of " SiO_2 " is zero.

TABLE 14

No.	Ba	Pb	Sr	Ca	Sm	Mn	SiO_2	
4-1	97.0	1	1	1	0.2	0.02	0	
4-2	60.0	10	15	15	0.2	0.02	0	
4-3	40.0	30	15	15	0.2	0.02	0	
4-4	20.0	50	15	15	0.2	0.02	0	*
4-5	30.0	50	10	10	0.2	0.02	0	
4-6	30.0	60	5	5	0.2	0.02	0	*
4-7	74.0	10	1	15	0.2	0.02	0	
4-8	45.0	10	30	15	0.2	0.02	0	
4-9	35.0	10	40	15	0.2	0.02	0	*
4-10	74.0	10	15	1	0.2	0.02	0	
4-11	50.0	10	15	25	0.2	0.02	0	
4-12	45.0	10	15	30	0.2	0.02	0	*

(The mark (*) denotes that the composition is out of the range of the present invention)

TABLE 10 (continued)

No.	FIRING ATMOSPHERE	HEAT-TREATMENT ATMOSPHERE	
3-4	H ₂ 1%/N ₂ 99%	O ₂ 100%	*
3-5	H ₂ 1%/N ₂ 99%	O ₂ 100%	
3-6	H ₂ 1%/N ₂ 99%	O ₂ 100%	*
3-7	H ₂ 1%/N ₂ 99%	O ₂ 100%	
3-8	H ₂ 1%/N ₂ 99%	O ₂ 100%	
3-9	H ₂ 1%/N ₂ 99%	O ₂ 100%	*
3-10	H ₂ 1%/N ₂ 99%	O ₂ 100%	
3-11	H ₂ 1%/N ₂ 99%	O ₂ 100%	
3-12	H ₂ 1%/N ₂ 99%	O ₂ 100%	*
3-13	H ₂ 1%/N ₂ 99%	O ₂ 100%	*
3-14	H ₂ 1%/N ₂ 99%	O ₂ 100%	
3-15	H ₂ 1%/N ₂ 99%	O ₂ 100%	
3-16	H ₂ 1%/N ₂ 99%	O ₂ 100%	*
3-17	H ₂ 1%/N ₂ 99%	O ₂ 100%	*
3-18	H ₂ 1%/N ₂ 99%	O ₂ 100%	
3-19	H ₂ 1%/N ₂ 99%	O ₂ 100%	
3-20	H ₂ 1%/N ₂ 99%	O ₂ 100%	*
3-21	H ₂ 1%/N ₂ 99%	O ₂ 100%	
3-22	H ₂ 1%/N ₂ 99%	O ₂ 100%	*

(The mark (*) denotes that the composition is out of the range of the present invention)

[0058] The resistivities at room temperature (ρ_{25}), static withstanding voltage, temperature resistance coefficient (α) and scattering of resistance (CV %) of each sample in TABLE 10 are shown in TABLE 11.

TABLE 11

No.	$\rho_{25}(\Omega \cdot \text{cm})$	STATIC WITHSTANDING VOLTAGE (V/mm)	$\alpha(\%/^{\circ}\text{C})$	SCATTERING OF RESISTIVITY (CV %)	
3-1	1.7	60	10.8	2.9	
3-2-1	2.3	70	12.8	3.2	
3-2-2	2.1	70	11.7	3.3	
3-3	2.6	85	13.8	3.5	
3-4	3.6	85	15.1	3.8	*
3-5	3.2	90	13.8	3.1	
3-6	3.6	75	13.5	3.8	*
3-7	2.0	60	11.0	3.2	
3-8	3.2	75	13.6	3.0	
3-9	4.3	70	14.0	3.8	*
3-10	2.1	65	11.2	3.0	
3-11	2.6	75	13.0	3.4	

(The mark (*) denotes that the composition is out of the range of the present invention)

TABLE 7 (continued)

No.	$\rho_{25}(\Omega\text{-cm})$	STATIC WITHSTANDING VOLTAGE	$\alpha(\%/^{\circ}\text{C})$	SCATTERING OF RESISTIVITY (CV %)	
2-2-2	2.2	70	12.0	3.1	
2-3	2.7	85	14.0	3.5	
2-4	3.6	85	15.1	3.9	*
2-5	3.3	90	14.1	3.1	
2-6	3.6	75	13.7	3.9	*
2-7	2.1	60	11.3	3.2	
2-8	3.2	75	13.6	3.4	
2-9	4.4	70	14.2	3.8	*
2-10	2.1	65	11.4	3.1	
2-11	2.8	75	13.2	3.4	
2-12	3.6	80	13.5	3.8	*
2-13	3.9	90	14.6	3.9	*
2-14	3.1	85	13.9	3.2	
2-15	2.4	65	11.1	3.1	
2-16	2.8	45	9.7	3.3	*
2-17	1.7	55	10.4	3.2	*
2-18	1.8	60	11.0	3.2	
2-19	3.2	85	14.0	3.6	
2-20	4.8	90	15.4	3.9	*
2-21	3.0	85	13.3	3.3	
2-22	3.7	80	13.7	3.5	*

(The mark (*) denotes that the composition is out of the range of the present invention)

[0046] The sample numbers 2-1 to 2-22 in TABLE 6 and 7 correspond to the sample numbers 1-1 to 1-22 in TABLE 1 and TABLE 2, respectively, in which the samples same sample numbers have the same compositions with each other.

[0047] The samples with the sample number 2-2 in TABLE 6 and TABLE 7 were thermally-treated under different two kinds of oxidative atmospheres in the firing profile shown in FIG. 1. Accordingly, the samples were distinguished with each other by attaching sub-numbers as 2-2-1 and 2-2-2.

[0048] TABLE 7 shows that the samples with the compositions within the range of the present invention have the resistivities at room temperature (ρ_{25}) of 3.5 $\Omega\text{-cm}$ or less, static withstanding voltages of 50 V/mm or more and temperature resistance coefficients of 11.0 $\%/^{\circ}\text{C}$, enabling to obtain the PTC thermistors with small variation of resistance (CV %).

[0049] When the resistivities at room temperature (ρ_{25}), is especially noticed, more lower values could be obtained in the samples in TABLE 6 and TABLE 7 having the compositions within the range of the present invention as compared with the samples in the foregoing TABLE 2 whose compositions are within the range of the present invention, because the effect of firing in a neutral atmosphere and heat-treatment in an oxidative atmosphere had been expressed to increase the grain size in the ceramic due to such firing and heat-treatment.

[0050] It is also evident from the comparison between the samples 2-2-1 and 2-2-2 in TABLE 6 and TABLE 7 that the oxygen concentration during the heat-treatment step in the firing profile shown in FIG. 1 has substantially no effects on the characteristics of the PTC thermistors in the oxygen concentration range from 20 to 100%.

[0051] Compare the samples having the compositions within the range of the present invention with the samples having the compositions out of the range of the present invention in TABLE 7, then the same tendencies as the comparison of these samples in TABLE 2 are recognizable.

[0052] The comparative examples in which semiconductor forming agents other than Sm were used are listed in

[0031] While all the samples 1-1 to 1-22 shown in TABLE 1 and TABLE 2 use Sm as the semiconductor forming agent, The samples denoted by (*) are out of the range of the present invention in their composition ratios.

[0032] It is evident from TABLE 1 and TABLE 2 that characteristics such as the resistivity at room temperature (ρ_{25}) of 5 $\Omega\cdot\text{cm}$ or less, static withstanding voltage of 60 V/mm or more and temperature resistance coefficient (α) of 10 %/ $^{\circ}\text{C}$ or more are obtained with less variation of the temperature resistance coefficient among the lots with respect to the PTC thermistors manufactured using the composite material for the PTC thermistors having the compositions within the range of the present invention.

[0033] In the samples 1-4, 1-6, 1-9, 1-12, 1-13, 1-20 and 1-22 having the compositions out of the range of the present invention have, on the other hand, the resistivity at room temperature (ρ_{25}) of more than 5 $\Omega\cdot\text{cm}$ while the samples 1-16 and 1-17 has the temperature resistance coefficient (α) of less than 10 %/ $^{\circ}\text{C}$.

[0034] Although it is possible to lower the resistivity at room temperature (ρ_{25}) in the samples 1-23, 1-25 and 1-26 in which La, Sb and Nb are used as semiconductor forming agents, respectively, in the comparative examples shown in TABLE 3 and TABLE 4, scattering of the values among the lots are increased as compared with the samples shown in TABLE 1 and TABLE 2. The resistivity at room temperature (ρ_{25}) can not be sufficiently lowered in the sample 1-24 in which Y is used as the semiconductor forming agent.

[0035] Accordingly, Sm is used for the semiconductor forming agent in the examples according to the present invention in order to obtaining the effects as hitherto described, because the ionic radius of Sm is appropriate for obtaining the foregoing effect.

[0036] TABLE 5 below show the ionic radii of the semiconductor forming agents used in the examples and comparative examples.

TABLE 5

	IONIC SPECIES	IONIC RADIUS (Å)
Ba SITE 12-COORDINATION NUMBER	Ba ²⁺	1.61
	La ³⁺	1.36
	Sm ³⁺	1.24
	Y ³⁺	0.96
Ti SITE 6-COORDINATION NUMBER	Ti ⁴⁺	0.61
	Nb ⁵⁺	0.64
	Sb ⁵⁺	0.60

[0037] While the Ba-site can be in principle substituted with the trivalent ions La, Sm and Y judging from ionic radii of these ions, a part of them are thought to occupy the Ti-site. The proportions of substitution of the Ti-site with these ions La, Sm and Y are supposed to be increased as the ionic radii of them become smaller, or in the order of Y > Sm > La. An acceptor level is generated when the Ti-site is substituted with these trivalent ions, trapping free electrons generated by substitution of the Ba site with these ions.

[0038] Accordingly, the trapping probability of the liberated free ions with the acceptors becomes higher when Y having small ionic radius and higher probability of Ti-site substitution is used for the semiconductor forming agent. Although the rate of change of the resistivity against the amount of addition of Y is small (the resistivity is stable to the amount of addition of Y), the resistivity of the thermistor has not been sufficiently reduced by the addition of Y as seen in the sample 1-24 in TABLE 4.

[0039] The acceptor level is hardly formed to reduce the resistivity when La having a higher tendency for substituting the Ba-site is used as the semiconductor forming agent. However, the rate of change of the resistivity against the addition of La becomes so large that dispersion of the resistivity among the lots becomes larger as shown in the sample 1-23 in TABLE 4.

[0040] Sm has an ability to lower the resistivity and reduce dispersion of the resistivity among the lots since the ionic radius of Sm is within an appropriate range.

[0041] While the Ti-site may be in principle substituted with Nb or Sb judging from their ionic radii, the acceptor level is never formed even when the Ti-site is substituted with Nb or Sb since the ion serves as a pentavalent ion, the ion serving as ions similar to La.

(Example 2)

[0042] The firing profile as shown in FIG. 1 is used in Example 2 in the firing step of the molded body comprising the

TABLE 1 (continued)

No.	Ba	Pb	Sr	Ca	Sm	Mn	SiO ₂	
1-16	60.0	10	15	15	0.4	0.02	1	*
1-17	60.0	10	15	15	0.2	0.005	1	*
1-18	60.0	10	15	15	0.2	0.01	1	
1-19	60.0	10	15	15	0.2	0.03	1	
1-20	60.0	10	15	15	0.2	0.04	1	*
1-21	60.0	10	15	15	0.2	0.02	2	
1-22	60.0	10	15	15	0.2	0.02	3	*

(The mark "*" denotes that the composition is out of the range of the present invention)

[0022] Each mixture with a composition shown in TABLE 1 was then dehydrated and dried and, after calcinating at 1100 to 1200°C, a binder was mixed for granulation. The granulated particles were subjected to a uniaxial press molding and the molded body obtained was fired at 1300 to 1400°C in the air to obtain a sintered disk with a diameter of 11.0 mm and a thickness of 0.5 mm.

[0023] Respective sintered disks were used for ceramics for use in the PTC thermistor. In-Ga electrodes were formed on each principal faces of the ceramic disk to obtain a PTC thermistor as a sample piece.

[0024] The resistivity at room temperature (ρ_{25}), static withstanding voltage and temperature resistance coefficient (α), as well as dispersion of the resistance (CV %), were determined with respect to the PTC thermistor using each sample.

[0025] In more detail, the temperature resistance coefficient (α) was calculated by the following equation:

$$\alpha = [\ln(\rho_2 / \rho_1) / (T_2 - T_1)] \times 100 (\%/^{\circ}\text{C})$$

wherein ρ_1 and T_1 denote the resistivity 10 time large than ρ_{25} and corresponding temperature, respectively, while ρ_2 and T_2 denote the resistivity 100 time large than ρ_{25} and corresponding temperature, respectively.

[0026] Scattering of the resistance (CV %) was evaluated from the variation of the resistivity at room temperature among each lot containing 10 pieces of the PTC thermistors manufactured under the same condition using respective compositions shown in TABLE 1. The values were actually determined by the following equation:

$$\text{CV \%} = (\text{standard deviation of } \rho_{25} \text{ among 10 lots}) / (\text{mean value of } \rho_{25} \text{ among 10 lots}) \times 100 (\%)$$

[0027] TABLE 2 shows the resistivity at room temperature (ρ_{25}), static withstanding voltage, temperature resistance coefficient (α) and its scattering (CV %).

TABLE 2

No.	$\rho_{25}(\Omega \cdot \text{cm})$	STATIC WITHSTANDING VOLTAGE (V/mm)	$\alpha(\%/^{\circ}\text{C})$	SCATTERING OF RESISTANCE (CV %)	
1-1	2.1	60	10.0	3.2	
1-2	3.1	90	11.5	3.5	
1-3	3.9	110	13.0	3.9	
1-4	5.3	120	14.1	3.8	*
1-5	4.9	110	13.1	3.9	
1-6	5.5	105	12.7	4.0	*
1-7	2.7	75	10.3	3.3	
1-8	4.5	100	12.6	3.8	

(The mark "*" denotes that the composition is out of the range of the present invention)

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BACKGROUND OF THE INVENTION

1. Field of the Invention

[0001] The present invention relates to a composite material for a positive temperature coefficient thermistor (referred to PTC thermistor hereinafter), ceramics for use in the PTC thermistor and a method for manufacturing the PTC thermistor.

2. Description of the Related Art

[0002] Related arts concerning the present invention are disclosed in Japanese laid-open Patent Application Nos. 3-88770 and No. 3-54165.

[0003] The former application discloses a barium titanate based semiconductor ceramic composition for use in the PTC thermistor containing as principal components 45 to 85 molar percentages (mol%) of BaTiO_3 , 1 to 20 mol% of PbTiO_3 , 1 to 20 mol% of SrTiO_3 and 5 to 20 mol% of CaTiO_3 as well as 0.1 to 0.3 mol% of a semiconductor forming agent, 0.006 to 0.025 mol% of Mn and 0.1 to 1 mol% of SiO_2 as additives, wherein BaTiO_3 , PbTiO_3 , SrTiO_3 and CaTiO_3 as principal components are formed by a citric acid method.

[0004] The application describes that characteristic values such as a resistivity at room temperature of $8 \Omega\text{-cm}$ or less (4 to $8 \Omega\text{-cm}$), a temperature resistance coefficient of $9\%/^\circ\text{C}$ or more and an static withstanding voltage of 60 V/mm or more can be obtained with respect to the ceramic composition as disclosed above. The laid-open also shows examples using La, Sb and Nb as semiconductor forming agents.

[0005] The latter laid-open discloses a barium titanate based semiconductor ceramic composition for use in the PTC thermistor containing as principal components 45 to 87 mol% of BaTiO_3 , 3 to 20 mol% of PbTiO_3 , 5 to 20 mol% of SrTiO_3 and 5 to 15 mol% of CaTiO_3 as well as 0.2 to 0.5 mol% of a semiconductor forming agent, 0.02 to 0.08 mol% of Mn and 0 to 0.45 mol% of SiO_2 as additives, wherein BaTiO_3 , PbTiO_3 , SrTiO_3 and CaTiO_3 as principal components are formed by a liquid phase method.

[0006] The publication shows that characteristic values such as a resistivity at room temperature of 3 to $10 \Omega\text{-cm}$ and an static withstanding voltage of 10 to 200 V/mm can be obtained with respect to the ceramic composition as disclosed above. It also shows examples using Sb, Y and La as semiconductor forming agents.

[0007] Any one of La, Sb, Nb and Y is used as a semiconductor forming agent in the examples disclosed in the foregoing two patent publications. However, these semiconductor forming agents involves following problems as shown in the comparative examples to be described hereinafter in the embodiment of the present invention.

[0008] Firstly, it is a problem that the resistance is largely dispersed when La, Sb or Nb is used for the semiconductor forming agent, although the resistivity at room temperature becomes low.

[0009] Secondly, the resistivity at room temperature can not be lowered when Y is used for the semiconductor forming agent.

SUMMARY OF THE INVENTION

[0010] The present invention provides a composite material for the PTC thermistor as well as a ceramic for use in the PTC thermistor obtained by firing the composite material, and a method for manufacturing the same.

[0011] In a first aspect, the present invention provides, in short, a composite material for the PTC thermistor using Sm as a semiconductor forming agent or, in more detail, a composite material for a PTC thermistor containing as principal components 30 to 97 molar percentages (mol%) of BaTiO_3 , 1 to 50 mol% of PbTiO_3 , 1 to 30 mol% of SrTiO_3 and 1 to 25 mol% of CaTiO_3 (wherein the total content of them accounts for 100 mol%), along with containing as additives 0.1 to 0.3 mole of Sm in terms of Sm element in a compound containing Sm, 0.01 to 0.03 mole of Mn in terms of Mn element in a compound containing Mn and 0 to 2.0 mole of Si in terms of Si element in a compound containing Si, relative to 100 mole of the principal components.

[0012] The present invention also provides a ceramic for use in the PTC thermistor obtained by firing the composite material as described above. In a second aspect, the present invention provides a ceramic for use in a PTC thermistor containing as principal components 30 to 97 molar percentages (mol%) of BaTiO_3 , 1 to 50 mol% of PbTiO_3 , 1 to 30 mol% of SrTiO_3 and 1 to 25 mol% of CaTiO_3 (wherein the total content of them accounts for 100 mol%), along with containing as additives 0.1 to 0.3 mole of Sm in terms of Sm element in samarium oxide, 0.01 to 0.03 mole of Mn in terms of Mn element in manganese oxide and 0 to 2.0 mole of Si in terms of Si element in silicon oxide, relative to 100 mole of the principal components.

[0013] The present invention also provides a ceramic for use in the PTC thermistor obtained by firing the composite